	Application No.	Applicant(s)	
Notice of Allowability	10/669,253	MIYAI ET AL.	
	Examiner	Art Unit	
	Bernard E. Souw	2881	(fw)
The MAILING DATE of this communication appears All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI of the Office or upon petition by the applicant, See 37 CFR 1.313 1. ☑ This communication is responsive to 08/23/2005 (RCE). 2. ☑ The allowed claim(s) is/are 1-14. 3. ☑ Acknowledgment is made of a claim for foreign priority undirection is made of a claim for foreign priority in the foreign priority is made of a claim for foreign priority in the foreign priority is made of a claim for foreign priority in the foreign priority is made of a claim for foreign priority in the foreign priority is made of a claim for foreign priority in the foreign priority is made of a claim for foreign priority in the foreign priority is	ears on the cover sheet with the county (OR REMAINS) CLOSED in this apport or other appropriate communication (GHTS. This application is subject to and MPEP 1308.	correspondence addrest polication. If not include in will be mailed in due of the withdrawal from issue the withdrawal from its with	ed course. THIS e at the initiative
* Certified copies not received:			
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONM THIS THREE-MONTH PERIOD IS NOT EXTENDABLE. 4. A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which give	ENT of this application. itted. Note the attached EXAMINER	R'S AMENDMENT or NO	
5. CORRECTED DRAWINGS (as "replacement sheets") mus			
(a) ☐ including changes required by the Notice of Draftsperson's Patent Drawing Review (PTO-948) attached			
1) hereto or 2) to Paper No./Mail Date			
(b) including changes required by the attached Examiner's Paper No./Mail Date			
Identifying indicia such as the application number (see 37 CFR 1, each sheet. Replacement sheet(s) should be labeled as such in the	.84(c)) should be written on the drawi he header according to 37 CFR 1.121(ngs in the front (not the lack).	back) of
6. DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL.			
Attachment(s) 1. ☑ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3. ☐ Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date 4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material	5. ☐ Notice of Informal F 6. ☐ Interview Summary Paper No./Mail Da 8), 7. ☐ Examiner's Amend 8. ☑ Examiner's Statem 9. ☐ Other	r (PTO-413), te ment/Comment	ŕ

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DETAILED ACTION

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Continued Examination Under 37 CFR 1.114

1. A request for continued examination under 37 CFR 1.114, including the fee set

forth in 37 CFR 1.17(e), was filed in this application after final rejection. Since this

application is eligible for continued examination under 37 CFR 1.114, and the fee set

forth in 37 CFR 1.17(e) has been timely paid, the finality of the previous Office action

has been withdrawn pursuant to 37 CFR 1.114. Applicant's submission filed on August

23, 2005 has been entered.

Amendment

2. The Amendment filed 08/23/2005 has been entered. The present Office Action is

made with all the arguments being fully considered.

Claims 1, 5, 6, 11 and 12 have been amended.

Claims 1-14 remain pending in this office action.

ALLOWANCE

3. Claims 1-14 are allowed.

Reasons for Allowance

4. The following is an examiner's statement of reasons for allowance:

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An inspection apparatus or method for irradiating a patterned sample with an electron beam, so that an inspection image and a reference image can be generated on the basis of a secondary electron or a reflected electron emitted by the sample, wherein an abnormal pattern is determined based on a difference in halftone values of each pixel between the inspection image and the reference image, the inspection apparatus or method further comprising: means for automatically obtaining defect information from the sample and generating a defect distribution chart containing a graphical display of defects for samples, in which a feature quantity of the abnormal pattern is used as a parameter, the feature quantity being based on a difference image and the inspection image, the difference image being obtained from the difference in halftone values of each pixel between the inspection image and the reference image; means for simultaneously displaying at least the inspection image, the reference image, and the abnormal pattern extraction image, as recited in claims 1, 6 and 12, is neither anticipated nor rendered obvious by any prior art.

Claims 2-5, 7-11, 13 and 14 are also allowed because of their dependencies, either directly or indirectly, upon claims 1, 6 or 12.

5. Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

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Relevant Prior Art

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6. This prior art made of record and not relied upon is considered pertinent to

applicant's disclosure: US PGPUB # 2001/0033683, issued to Tanaka et al. However.

Tanaka et al. does not teach the limitation regarding a defect distribution chart

containing a graphical display of defects for samples and a simultaneous display the

inspection image, the reference image, and the abnormal extraction image.

Communications

7. Any inquiry concerning this communication or earlier communications from the

examiner should be directed to Bernard E Souw whose telephone number is 571 272

2482. The examiner can normally be reached on Monday thru Friday, 9:00 am to 5:00

pm..

If attempts to reach the examiner by telephone are unsuccessful, the examiner's

supervisor, John R Lee can be reached on 571 272 2477. The central fax phone

number for the organization where this application or proceeding is assigned is 571 273

8300 for regular communications as well as for After Final communications.

Any inquiry of a general nature or relating to the status of this application or

proceeding should be directed to the receptionist whose telephone number is 571 272

5993.

bes

November 04, 2005

/JOHN R. LE

uperysory patent examiner

TECHNOLOGY CENTER 2800